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Novel in-situ button shear methodology for efficient assessment of mold compound encapsulation

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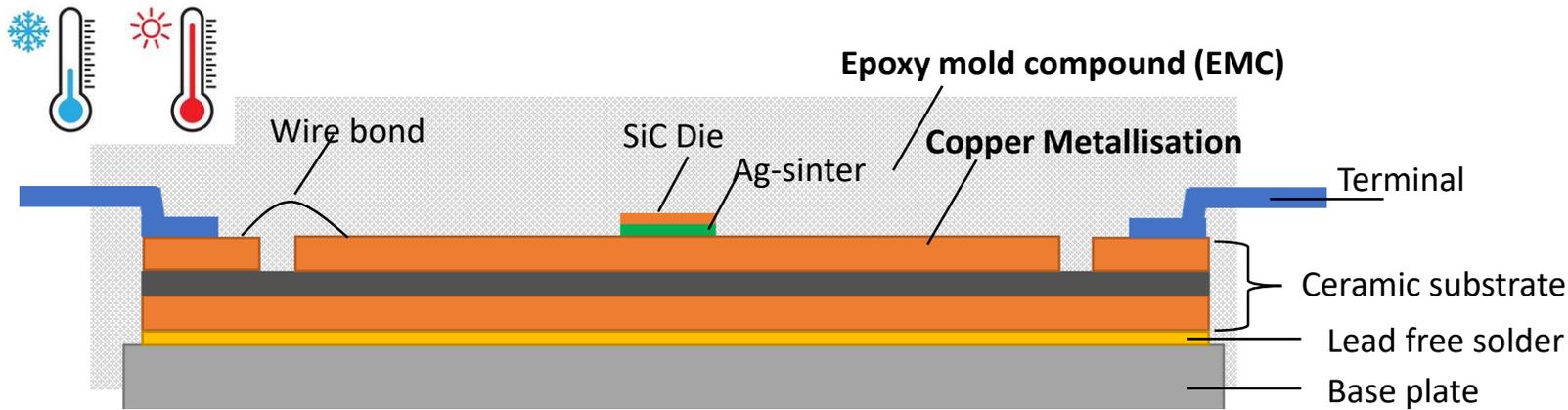
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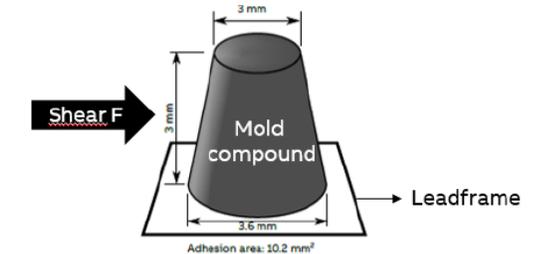
- Motivation
- Integrity of Button sample preparation
- In-situ button shear methodology
- Comparison of button preparation methods
- Impact of Plasma preconditioning on EMC adhesion
- Impact of reliability tests on EMC adhesion strength
- Conclusion



- Technology trend of large volume epoxy molding for power modules in e-mobility application
- Reliability of the device depends on good adhesion of back-end encapsulation material
- Limitations from the establish test method [SEMI G69-0996] used by Epoxy mold compound supplier



Transfer molded Power module package



Adhesive area	Leadframe thickness	Height of mold compound
10 ± 0.5mm ²	0.15mm	3 ± 0.15mm

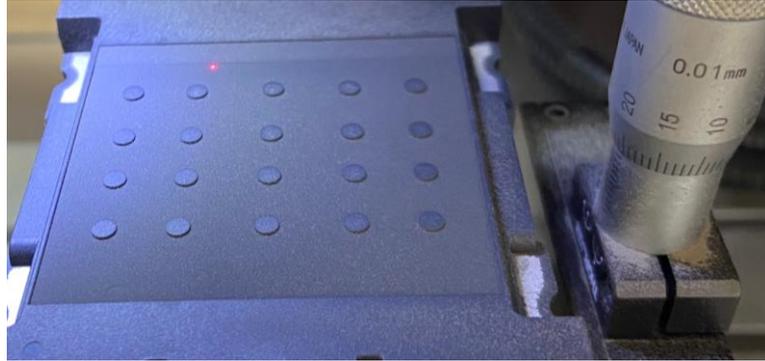
Std. button shear test

Demonstration of the novel in-situ button shear methodology ECTC 2021 & 2022, PCIM 2023

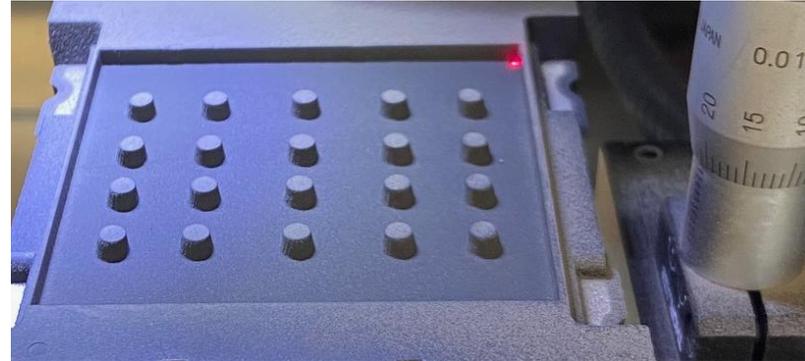
Button shaping by laser ablation



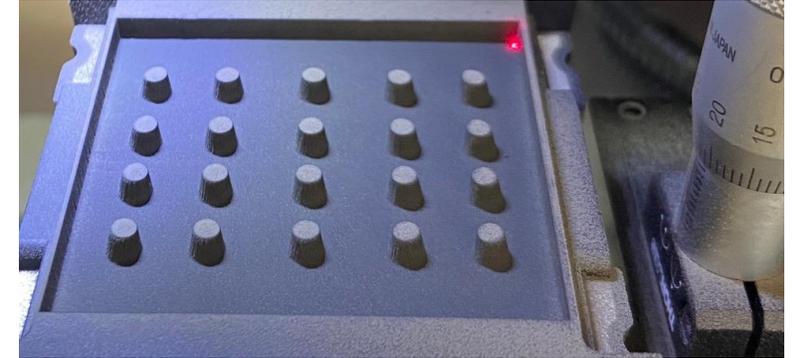
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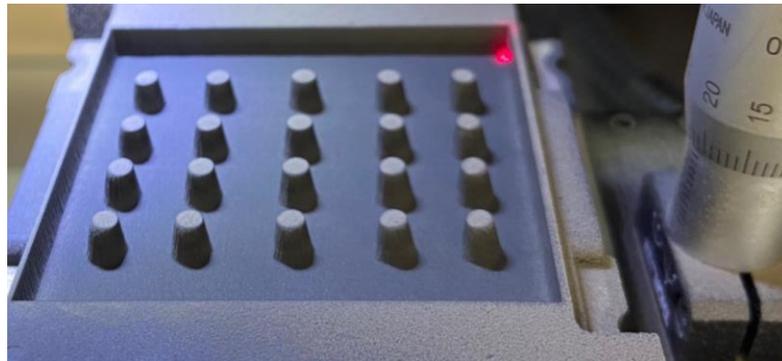
X10repetitions



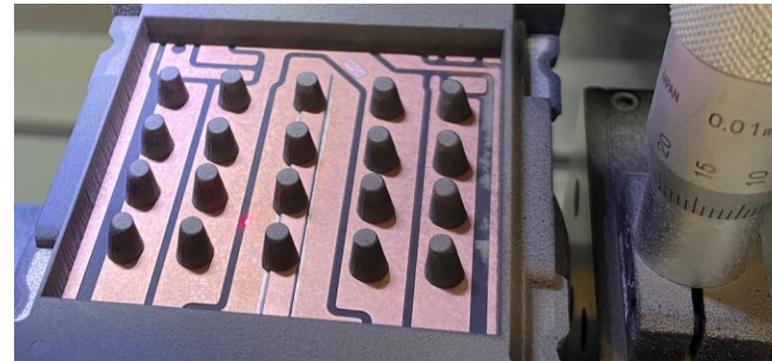
X30repetitions



X60repetitions



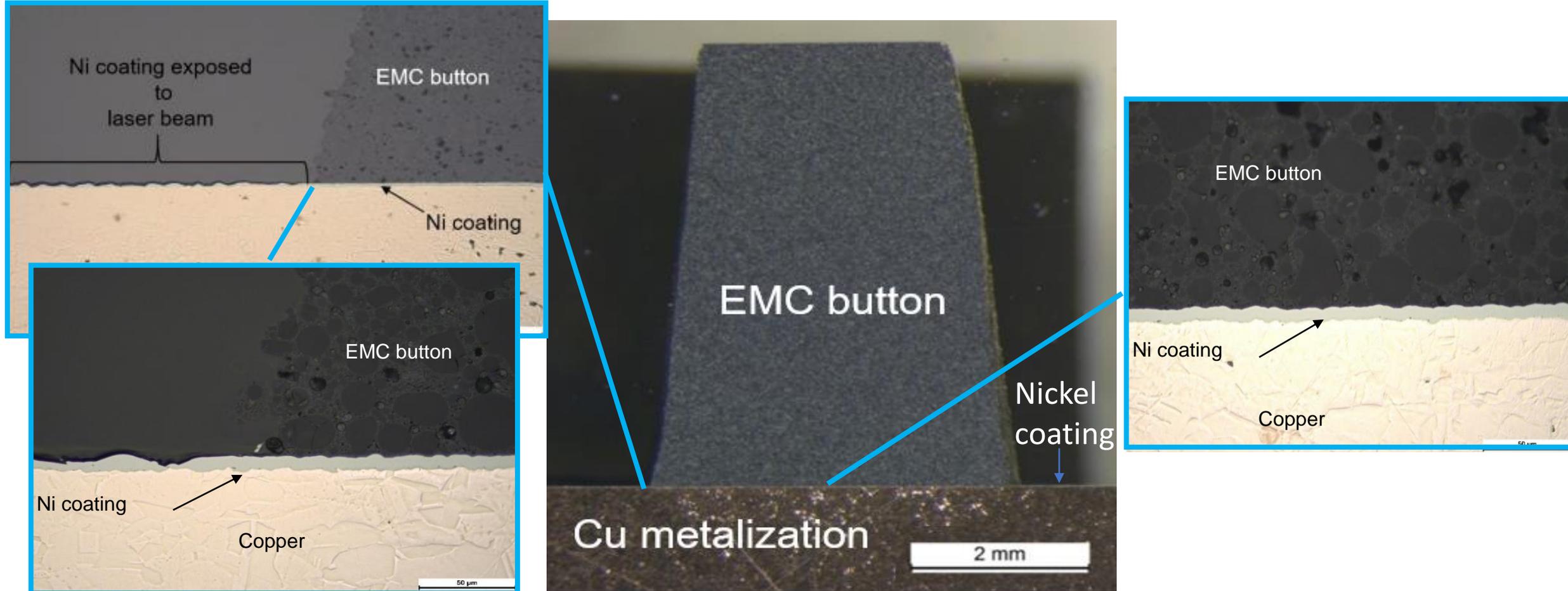
X80repetitions



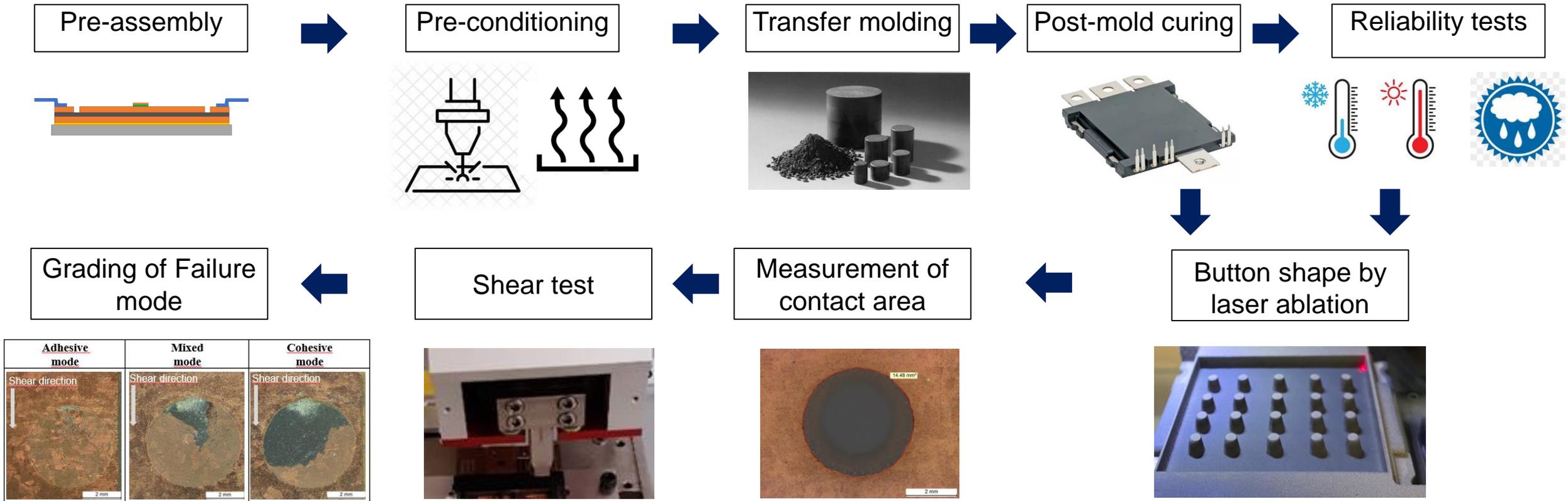
X100repetitions

Ablation rate optimized with process parameters

Integrity check of Button sample preparation

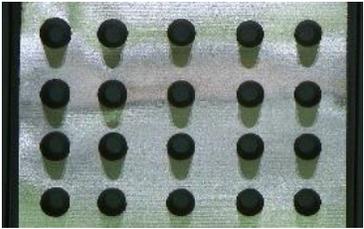
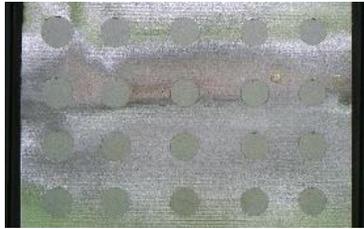
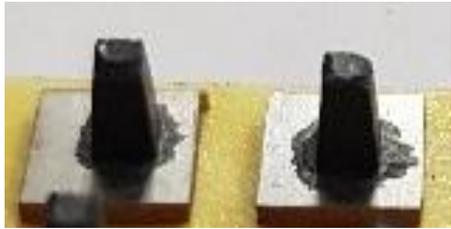


No harmful impact at Region of Interest



Through process on EMC characterization

Comparison of button preparation methods

		Buttons prepared according to novel in-situ laser ablation method		Buttons prepared according to SEMI G69-0996 by EMC supplier (standard)	
Buttons before Shearing	Surface after Shearing				
# of buttons		40		6	
Failure mode		100% adhesive		50% adhesive & 50% mixed	
Average shear strength		8.6 ± 2.2Mpa		17.6 ± 7.4Mpa	
Assessment +/-		+ Distinct button edges and contact area + failure mode grading + narrow data distribution		- EMC Flash around buttons -Large data distribution -Dedicated mold tool	

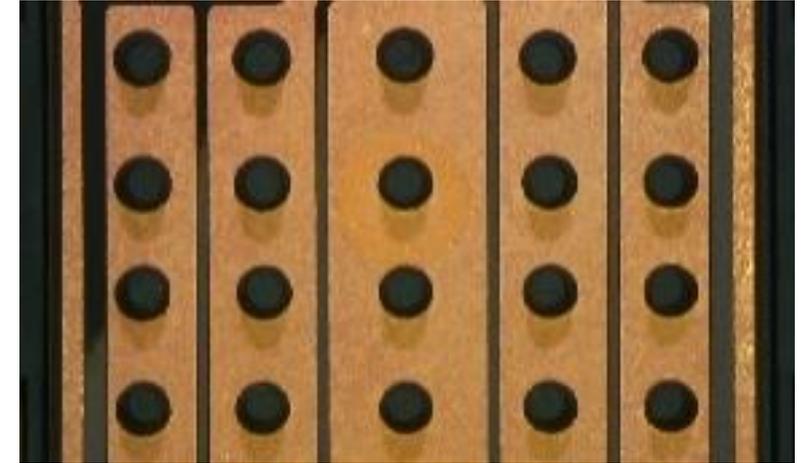
Advantage towards standard methodology

Motivation:

- Test efficiency of In-situ button shear method by optimizing Argon plasma recipe for Copper surface pre- conditioning prior molding

DOE setup:

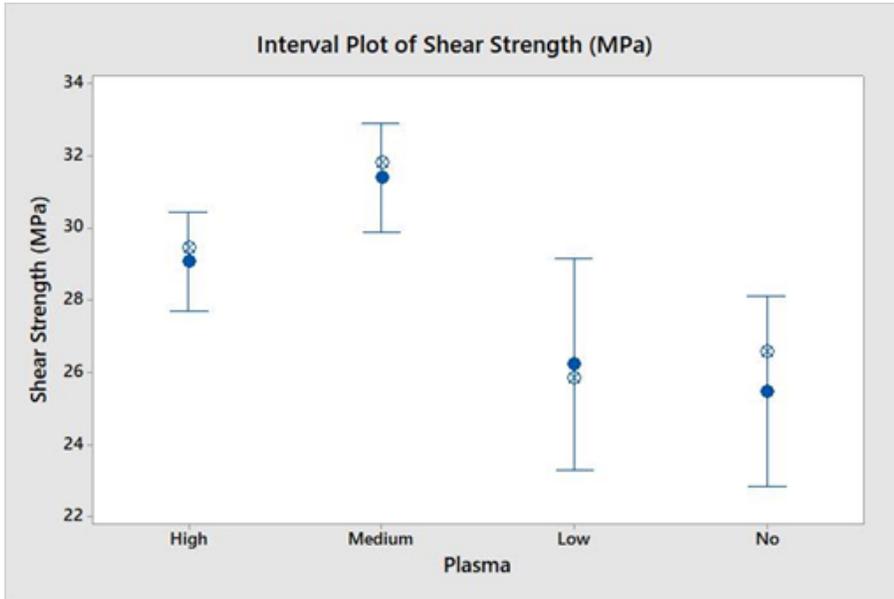
- 3 splits with Argon plasma programs (Low, Medium, High intensity)
- 1 reference without plasma
- 40 buttons per each split
- Response: shear strength, failure mode



EMC Buttons before shearing

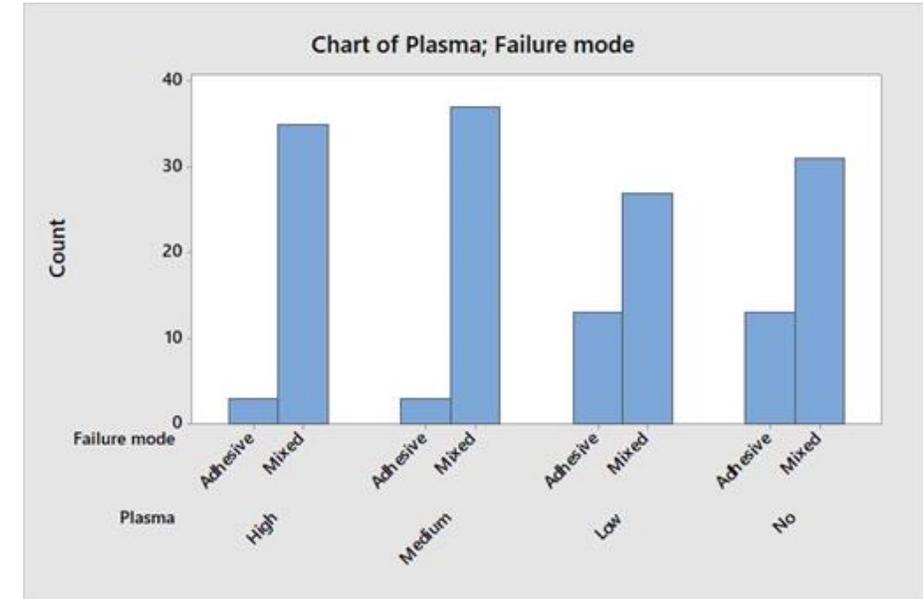
Checking impact from surface preparation on EMC adhesion

Shear strength vs. Plasma pre-conditioning



Medium & High plasma activation have similar average shear strength & lower spread of the data compared to **Low** or **No** plasma activation

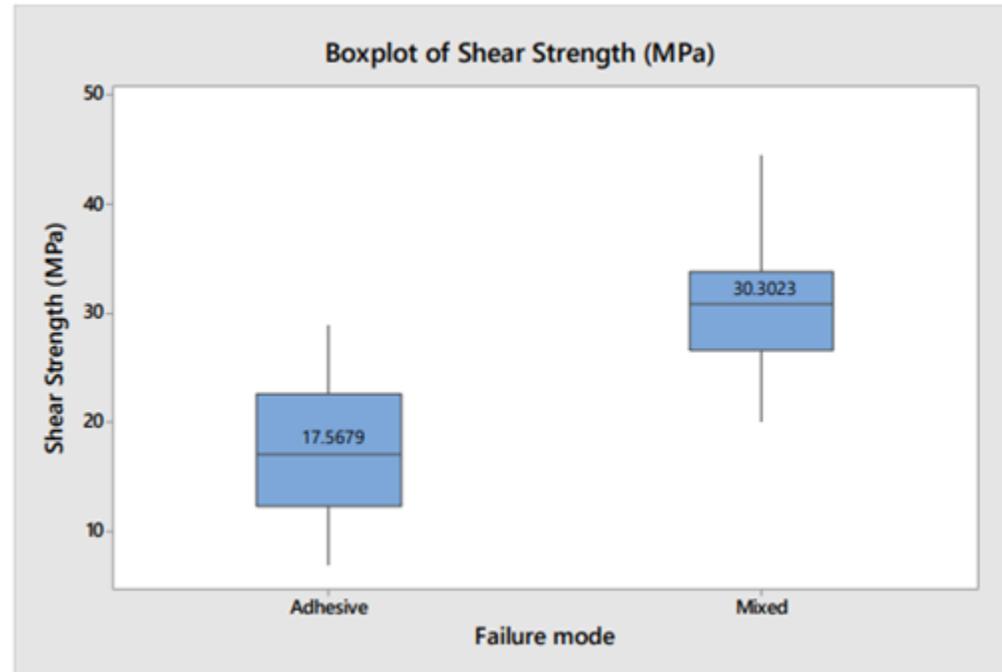
Failure mode vs. Plasma pre-conditioning



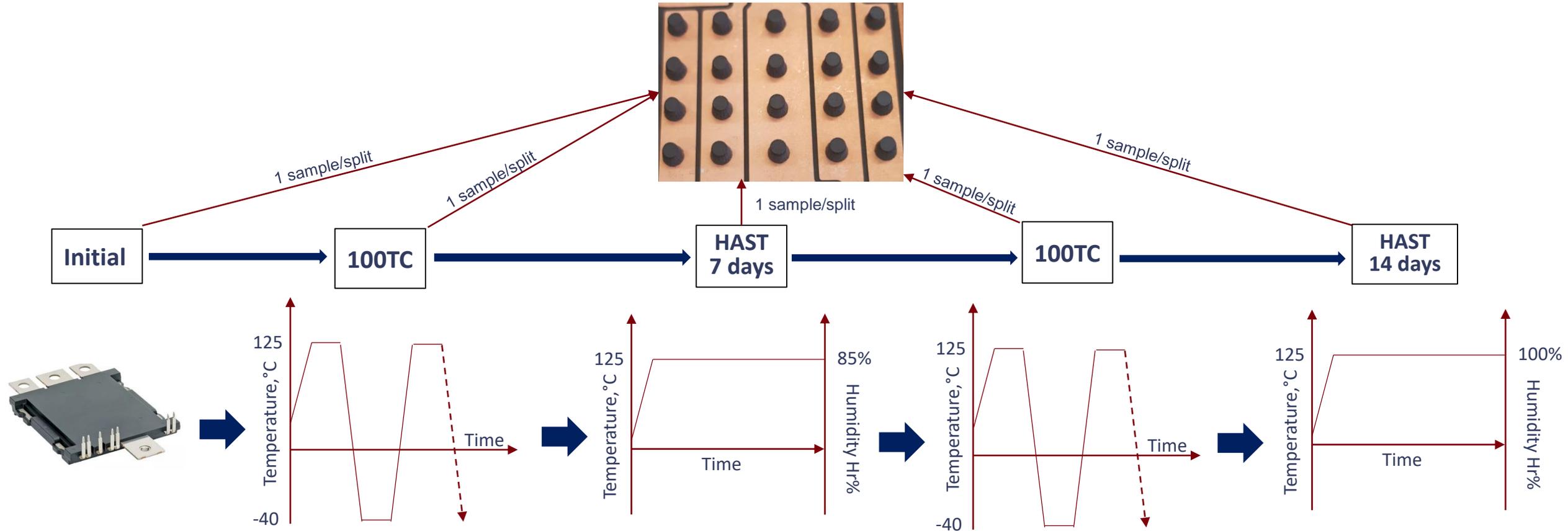
Frequency of **Adhesives** failure mode increases with **No** or **Low** plasma pre-conditioning

Validation of button shear methodology

Shear strength vs. Failure mode

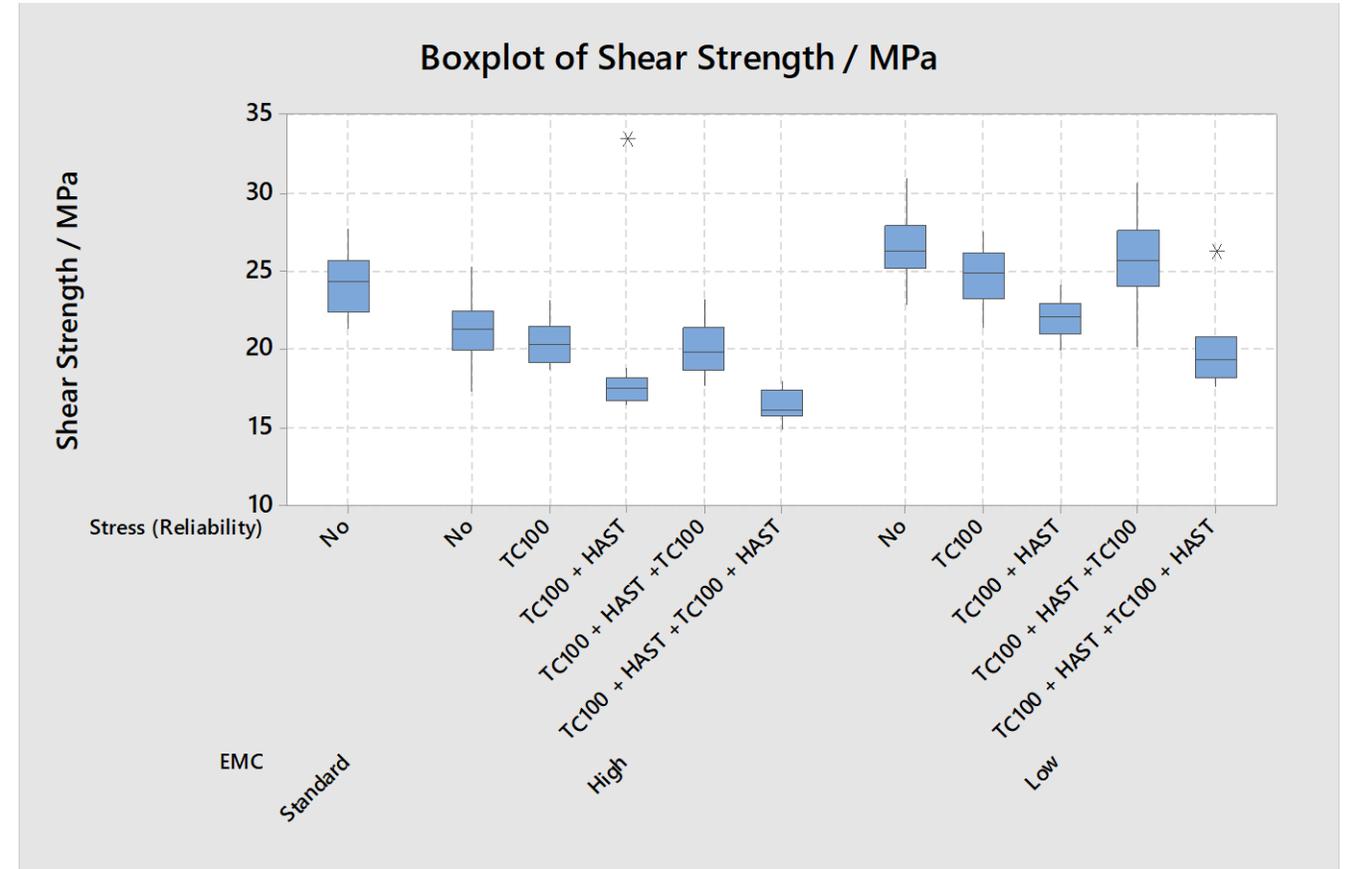


Overall adhesive failure mode shows lower shear strength value compared to mixed mode



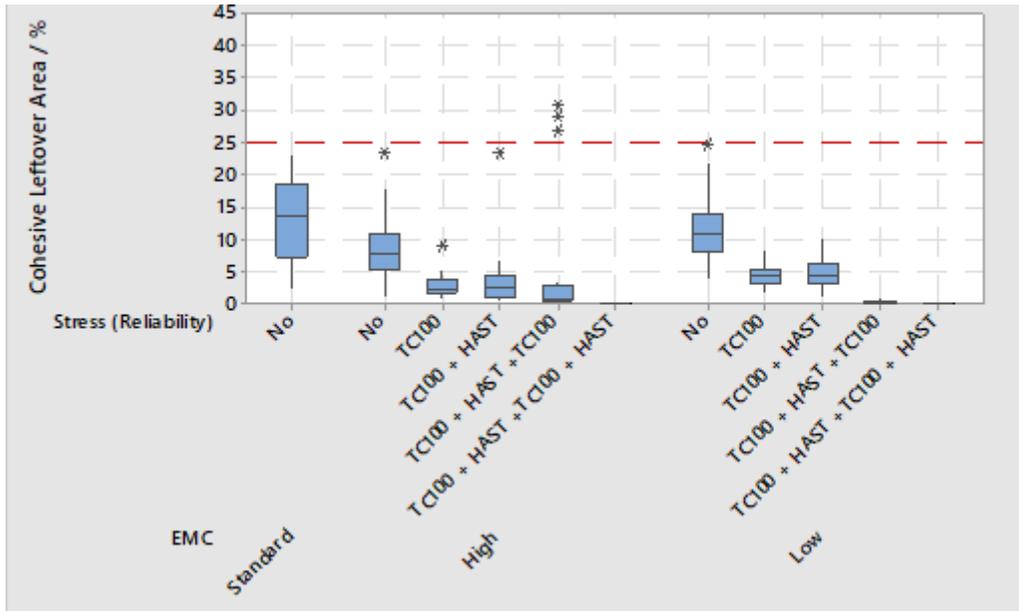
After each reliability test one sample/split was prepared for button shear

- Significant decrease after TC100 & HAST
- After the 2nd TC100 the shear strength values recover
- The 2nd HAST shows shear strength values even lower than after 1st HAST



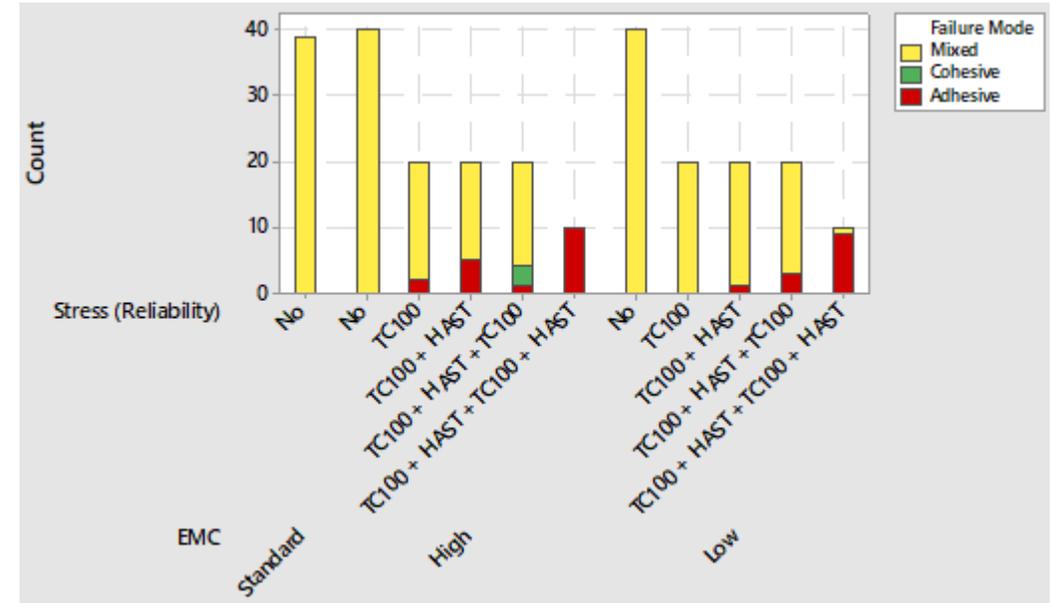
EMC adhesion strength sensitive to Humidity and Temperature exposure

Cohesive leftover area in % of ≠ EMC materials after testing



- Largest amount of cohesive area before reliability tests
- Cohesive area decreases after each tests

Count of failure mode of ≠ EMC materials depending on testing



- Cohesive mode after TC stress indicates signs of material degradation, whereas adhesive mode after humidity stress indicates signs of interface degradation

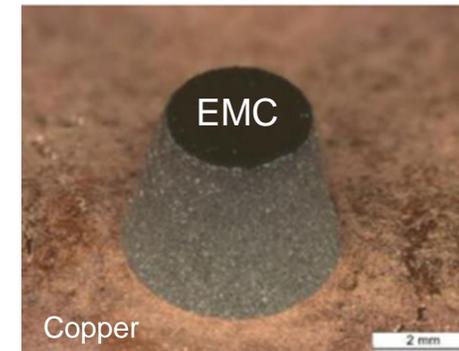
Humidity and thermal stress leading to different failure modes

Conclusion

- Integrity of EMC Button validated
- Comparative DOE's performed on standard vs. In-situ button method
- Efficiency of the In-situ button test method demonstrated through positive impact of plasma as pre-conditioning before molding
- Efficiency of the In-situ button test method to demonstrate the reliability performance of the molded product
- After humidity/ thermal stress exposure the failure mode changes to adhesive mode leading to significant shear force reduction

Outlook

- Optimization of Pre-conditioning steps
- Optimization of mold process parameters
- Impact of flow behaviour & material homogeneity
- Impact from product geometry & residual stress
- Impact of reliability tests performed on product level
- ...



Learnings use to define material specification for our molded product



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